

The Spectra-Physics® VGEN series of lasers deliver exceptional reliability and versatility for a wide range of applications. Housed in a robust assembly that meets industrial standards and fitted with a metal armored fiber cable, VGEN lasers deliver a high quality, near diffraction-limited output beam. VGEN's solid construction is maintenance free and reliable, ensuring long-life operation at low operational cost.

VGEN-QS lasers are pulsed, Ytterbium fiber lasers in a unique Q-switched configuration. Incorporating leading edge technology, the VGEN-QS series provides top performance in a wide range of precision-intensive industrial applications such as micromachining, fine processing, marking, engraving, and scribing. The VGEN-QS-HE (high energy) lasers offer very high pulse energy and are ideal for metal processing applications such as drilling and deep engraving. With low weight and small size, the VGEN-QS series is easily deployed.

The VGEN-ISP-POD is an IR short pulse MOPA (master oscillator power amplifier) fiber laser with pulse-on-demand capabilities for precision micromachining and marking applications. The pulse-on-demand capabilities of the VGEN-ISP-POD allow the user to control each individual pulse, enabling high resolution raster/image marking and precise micromachining of fine structures. VGEN-ISP-POD also features short pulse width down to 3 ns, high peak power up to 25 kW, and superior beam quality for high speed and high quality results.

VGEN-G series of pulsed green fiber lasers (532 nm) incorporate cutting edge technology to provide top performance for such precision-intensive applications as a solar cell, micro machining, silicon scribing, fine processing and thin film cutting. The VGEN-G lasers are comprised of short-pulse, linearly polarized Ytterbium fiber lasers in MOPA configuration along with SHG (second harmonic generation) module, providing an output power of up to 30 W. VGEN-G lasers offer a high pulse repetition rate (up to 1.5 MHz) combined with a very short pulse (tunable down to 3 ns) and high peak power which enable high system throughput for maximum operation efficiency.

Recommended Optics & Optomechanics

It is critical to choose the right optics and optomechanical components that work best with your VGEN laser. VGEN's IR and green output power necessitates optics that have a high damage threshold. MKS Newport offers a wide selection of the highest quality optics and optical components covering the entire spectrum UV, VIS, NIR and IR wavelengths to help you with your most challenging applications. In addition, for more than 30 years, we have manufactured the world's most comprehensive line of optical mounts and mechanics. Our precision optomechanics help our customers stay at the leading edge. MKS also offers LaserCleanTM components for low-contamination applications.

Please use the following recommendations to determine which components best serve your needs. If you need help making a selection or have questions about the following tables, please contact us at tech@newport.com.



VGEN Component Selection Guide

Recommended Optics & Optomechanics

Digital Digi	Ontice					Ontomochanics			VGEN OS				VCEN C				VGEN-ISP-POD			
Topic A Number LIDT Description P/N Mount Description Size A A A A A A A A A	Optics			Optomechanics			VGEN-QS				VGEN-G				VG	EN-I	SP-I	POD		
10.000 1	λ			LIDT	Description		Mount Description	40	145.	NE.	HEI	0,0	P	HE.	O HE?	D K	ro g	₂ 0	40	15
Milmons 1004 mm 0004cest Milmons 1004 mm 0004cest Milmons Mi	532 nn	m 10QM20HM.35	120HM.35		1" dia Mirror, 45° AOI	9817-6-Ni-K						•	•	•	•	•				
Minrors 1004 mt 1002/Mc 10 mt 1002 mt 1 mt 1 mt 1002 mt 1 mt	532 nn	m 10Q20HE.2)20HE.2		1" dia Mirror, 45° AOI	9814-6-Ni-K						•	•	•	•	•				
1004 no	1064 nı	10QM20HM.15			1" dia Mirror, 45° AOI	9817-6		•	•	•	•						•	•	•	•
Description	1064 nı	10Q20HE.1			1" dia Mirror, 45° AOI	9814-6		•	•	•	•						•	•	•	•
Coulon Basis Coulon Coulon Basis Coulon Bas	532 nn	m 05BC15PH.3	C15PH.3			UGP-1 and UGP-KIT-1						•	•	•	•	•				
SSZ mm 106P0-16 20m² 820m² 106 more of 1/4 wavepate 106 more of	1064 nı	o5BC15PH.9	C15PH.9		0.5" Polarizing Cube BS	9481(-M)		•	•	•	•						•	•	•	•
1064 nm 05FP02-34 2-bit m 1067 nm 1067 nm 2-bit m 2-	532 nn	m 10RP02-16	RP02-16 ²		1" dia zero order 1/2 waveplate	RSP-1T						•	•	•	•	•				
Waveplates 1064 nm	532 nn	m 10RP04-16	RP04-16 2		1" dia zero order 1/4 waveplate	GM-1RA	Gimbal Tip/Tilt Rotation Mount, Ø1 in., 100 TPI					•	•	•	•	•				
1064 mm 1069Pd-34 1064 mm 1069Pd-34 1066 mm	1064 nı	o5RP02-34	RP02-34 2		1/2" dia zero order 1/2 waveplate	(M-) MT-RS		•		•										
1064 nm 108P04-34 2, 3uch of 1064 nm 108P04-34 2, 3uch of 1064 nm 107 da zero order 1/4 waveplate 06M-1RA 6inhall Tp/Till Rotation Mount, 01 in., 100 TPI 2 2 2 2 2 2 2 2 2	1064 nı	10RP02-34	RP02-34 2		1" dia zero order 1/2 waveplate	RSP-1T		•	•	•	•							•	•	•
S32 mm SPXxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxx	1064 nı	o5RP04-34	RP04-34 2.		1/2" dia zero order 1/4 waveplate	(M-) MT-RS		•		•	•									•
S32 nm SBXXXXAR1.4 10 m, 2014 25.4 mm 25.4	1064 ni	m 10RP04-34	RP04-34 2.		1" dia zero order 1/4 waveplate	GM-1RA	Gimbal Tip/Tilt Rotation Mount, Ø1 in., 100 TPI	•	•	•	•						•	•	•	•
S32 nm SBXxxxAR.14 75-stem* @ 532 mm SBXxxxAR.14 75-stem* @ 532 mm SPXxxAR.14 75-stem* @ 532 mm SPXxxxAR.14 75-stem* @ 532 mm SPXxxxAR.13 75-stem* @ 532 mm SPXxxxAR.13 75-stem* @ 532 mm SPXxxxAR.13 75-stem* @ 532 mm SPXxxxAR.14 75-stem* @ 532 mm SPXxxxAR.15 75-stem* @ 532 mm 75-stem*	532 nn	m SPXxxxAR.14	oxAR.14 7.5			LA1V-XY	XY Compact Lens Positioner, 1.0 in. Diameter					•	•	•	•	•				
S32 nm SPCxxxAR.14 7.5 Junn 9.32 nm Plano concave lens, fused silica, 25.4 mm LP-1A-XY XY Lens Positioner, 1.0 in. (25.4 mm) Diameter S32 nm SPCxxxAR.14 7.5 Junn 9.32 nm Plano concave lens, fused silica, 25.4 mm LP-1A XYZ QXGY Lens Positioner, 1.0 in. Diameter S32 nm SPCxxxAR.33 7.5 Junn 9.32 nm Plano concave lens, fused silica, 25.4 mm Non-201c 25.4 mm Non-201c 25.4 mm Non-201c	532 nn	m SBXxxxAR.14	000 000 000 000 000 000 000 000 000 00		Bi-convex lens, fused silica,	P100-At38						•	•	•	•	•				
CAR-14 for 1064 nm SPXxxxAR.33 75.3 lcm² 1064 nm 25.5 d mm 10m. 70 ltz 25.4 d mm 25.4 d	532 nn	m SPCxxxAR.14	xxAR.14 7.5		Plano-concave lens, fused silica,	LP-1A-XY						•	•		•	•				
ARA.33 for 1064 nm	532 nn	m SBCxxxAR.14	xxxAR.14 7.5			LP-1A	XYZ \text{OX}\text{OY} Lens Positioner, 1.0 in. Diameter					•	•	•	•	•				
1064 nm	1064 ni	m SPXxxxAR.33			Plano-convex lens, fused silica,	(M-)LH-1A	A-LINE Fixed Lens Mount, Ø 1.0 in., 8-32(M4) Thd.											•		
1064 nm SPCxxxAR.33 7.5 Jcm² @ 1064 mm, 10 ns, 20 hz 25.4 mm 1064 nm SBCxxAR.33 7.5 Jcm² @ 1064 mm, 10 ns, 20 hz 25.4 mm 1064 nm SPCxxxAR.2 8 Jcm² @ 532 mm, 20 ns, 10 hz 20	1064 ni	sBXxxxAR.33				LA1V-XY	XY Compact Lens Positioner, Ø 1.0 in.	•	•	•	•							•	•	•
SBCXXAR.3 nm, 10 ns, 20 Hz 25.4 mm SPXxxxAR.2 sum, 4R.2 coated 20 ns, 10 Hz 20 ns	1064 ni	sPCxxxAR.33			Plano-concave lens, fused silica,	LPV-1	XYZ OXOY Compact Lens Positioners, Ø 1.0 in.		•		•						•	•	•	•
High Energy Plano-Convex Lens, 10 Hz 20 ns, 10 Hz 25.4 mm, AR.2 coated 25.4 mm, AR.2 coated 25.4 mm, AR.1 coated 2	1064 nı	SBCxxxAR.33				LPV-1	XYZ ⊕X⊕Y Compact Lens Positioners, Ø 1.0 in.	•	•	•	•						•	•	•	•
Plano-Convex Lenses 1064 nm SPXxxxAR.1 15 J/cm² @ 1064 nm 20 ns, 10 Hz 532 nm SPXxxxAR.S 532 nm NA.532 CANEX SPXXXXXXX Motorized Variable Attenuator Plano-Convex Lens, Nano-Textured Fused Silica, 12.7 mm LP-05A LP-05A-XYZ XYZ Lens Positioner, 0.5-in. Diameter • • • • • • • • • • • • • • • • • • •	532 nn	m SPXxxxAR.2	xxxAR.2 8			LP-1A	XYZ Θ X Θ Y Lens Positioner, 1.0 in. Diameter					•	•	•	•	•				
SPXxxxRAR.S 35 J/cm² @ 1064 nm SPXxxxRAR.L 35 J/cm² @ 1064 nm SPXxxxxRAR.L 35 J/cm² @ 1064 nm SPXxxxxRAR.L 35 J/cm² @ 1064 nm SPXxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxxx	1064 nı	sPXxxxAR.1	xxxAR.1			LP-1A	XYZ \text{OXOY Lens Positioner, \(\text{Ø 1.0 in.} \)	•	•	•	•						•	•	•	•
Nano- Texture Surface Lenses 1064 nm SPXxxxRAR.L 35 J/cm² @ 1064 nm 10 ns, 10 Hz Plano-Convex Lens, Nano- Textured Fused Silica, 12.7 mm Nano- Textured Fused Silica,	532 nn	m SPXxxxRAR.S	xxxRAR.S 35			LP-05A	XYZ ΘXΘY Lens Positioner,0.5 in. Diameter					•	•	•	•	•				
Texture Surface Lenses 1064 nm SPXxxxRAR.L 35 J/cm² @ 1064 nm, 10 ns, 10 Hz Plano-Convex Lens, Nano-Textured Fused Silica, 12.7 mm Plano-Convex Lens, Nano-Textured Fused Silica, 12.7 mm Plano-Convex Lens, Nano-Textured Fused Silica, 12.7 mm LP-05A XYZ Ens Positioner, 0.5-in. Diameter **Output** **Output** **Defectation of the convex lens, Nano-Textured Fused Silica, 12.7 mm Plano-Convex Lens, Nano-Textured Fused Silica, 12.7 mm LP-05A XYZ ØXØY Lens Positioner, 0.5 in. Diameter **Output** **Out	532 nn	m SPCxxxRAR.S	oxxRAR.S 35			LP-05A-XYZ	XYZ Lens Positioner, 0.5-in.Diameter					•	•	•	•	•				
Lenses 1064 nm SPCxxxRAR.L 35 J/cm² @ 1064 nm, 10 ns, 10 Hz Plano-Concave Lens, Nano-Textured Fused Silica, 12.7 mm LP-05A XYZ ØXØY Lens Positioner, 0.5 in. Diameter • • • • • • • • • • • • • • • • • • •	1064 ni	m SPXxxxRAR.L	oxxRAR.L 35			LP-05A-XYZ	XYZ Lens Positioner, 0.5-in.Diameter	•	•		•						•	•	•	•
532 IIII VA-532 10 ns, 10 Hz Mariual Variable Attenuator, PS-series 1.0 in Pedestal Spaces & Evtancians 1.0 in Pedestal Spaces & Evtancians & Evtanc	1064 ni	m SPCxxxRAR.L	xxxRAR.L 35			LP-05A	XYZ ΘXΘY Lens Positioner,0.5 in. Diameter	•	•	•	•					•	•	•	•	•
	532 nn	m VA-532	A-532 ²		Manual Variable Attenuator	Pedestal Forks	1.0 in. Pedestal Base Clamping Forks					•	•	•	•	•				
	532 nn	m VA-532-CONEX	32-CONEX 2			PS-series Pedestal Spacers	1.0 in. Pedestal Spacers & Extensions					•	•	•	•	•				
Attenuators 1064 nm VA-1064 2 J/cm² @ 1064 nm, 10 ns, 10 Hz Manual Variable Attenuator PS- series Pedestal Posts 1.0 in. Optical Pedestals, Graduated Diameter • • • • • • • •	1064 nı	vA-1064	-1064		Manual Variable Attenuator	·		•	•	•	•						•	•	•	
1064 nm VA-1064-CONEX 2 J/cm² @ 1064 nm, 10 ns, 10 Hz CONEX Pedestal Posts Pedestal Posts Pedestal Posts Pedestal Posts Porkless Optical Pedestals and Posts • • • • • •	1064 ni	VA-1064-CONEX	64-CONEX 2			PX Forkless	1.0 in. PX Forkless Optical Pedestals and Posts	•	•	•	•						•	•	•	•

^{*} Multiple lenses can be mounted with Newport's lens tubes and spacers

** Additional optics types and sizes are available – please go to http://www.newport.com or contact your local MKS sales representative

*** The optics listed in this guide will meet the requirements of most customer applications for the VGEN laser. Not all optics have been tested for all potential VGEN applications, so compatibility with all applications cannot be guaranteed. When selecting optics, please evaluate suitability for requirements of your application. If you need assistance, please contact your local MKS sales representative

Recommended Laser Measurement Sensors*



For optimal application results, it is critical to ensure that the delivered laser power at the sample is precisely controlled. Laser power sensor is a detector that absorbs a laser beam and outputs a signal proportional to the beam's power. MKS Newport offers a wide selection of power sensors to accurately measure the VGEN laser power delivered to the sample. The specific type of sensor depends on the details of the laser beam being measured, including power level, spectral region, beam size, etc.

VGEN Type	VGEN Model	Recommended Sensor	Laser Damage Threshold	Aperture	Power/Energy Measurement Range	Spectral Range	Description		
	VGEN-QS-50		12 kW/cm²	26 mm		0.19 to 11 μm			
VGEN-QS	VGEN-QS-HE-50	919P-150-26			50 mW to 150 W; 20 mJ to 100 J				
	VGEN-QS-HE-75	9197-150-26							
	VGEN-QS-HE-100								
	VGEN-G-10		20 kW/cm ²	17.5 mm					
	VGEN-G-20	919P-030-18			20mW to 30W; 6mJ to 30J		Spectrally flat broadband coating NIST-traceable calibration included Insensitive to beam position		
VGEN-G	VGEN-G-HE-10								
	VGEN-G-HE-20						Sensitive with low noise & drift		
	VGEN-G-HE-30	919P-050-26	12 kW/cm ²	26 mm	40mW to 50W; 20mJ to 30J				
	VGEN-ISP-POD-20	919P-030-18	20 kW/cm ²	17.5 mm	20mW to 30W; 6mJ to 30J				
VICEN ICD DOD	VGEN-ISP-POD-30	919P-050-26	12 kW/cm ²	26 mm	40mW to 50W; 20mJ to 30J				
VGEN-ISP-POD	VGEN-ISP-POD-50	919P-150-26	12 kW/cm ²	26 mm	50 mW to 150 W;				
	VGEN-ISP-POD-75	9191-100-20		20 111111	20 mJ to 100 J				

^{*} Order a 1 inch optical post holder PS-B-1 and a fork PS-F to mount the sensor vertically

Recommended Power Meter*

1919-R is one of MKS Newport's most feature rich and technologically advanced power meters. It offers a plug-and-play functionality and is compatible with almost any of the wide range of Newport sensors. 1919-R is also the most precisely calibrated unit on the market thus measuring with the highest accuracy. With its versatility, ease of use, and user-friendly interface, the sensor can be used stand-alone or interfaced with LabVIEW or the user's own software.

Power Meter	Part Number	Description
3.49. 3.49.	1919-R	Compatible with all standard Newport thermal sensors USB and RS232 interfaces with PMManager PC applications and User Commands document LabVIEW driver and COM Object Interface Select between English, Japanese, Russian, and Chinese interfaces

PC Interface (optional)

A PC interface allows you to connect your laser power sensor directly to the PC. The Model 841-PE-USB is a Power Meter with a USB connection to use a computer as the monitor, allowing the user to access the full computing power of the PC.

PC Interface	Part Number	Description
.56	841-PE-USB	 Optical Power and Energy Meter, Virtual, USB Ideal when equipment space is tight or there is a need to control multiple power meter channels Has a USB output and 0-1 V analog output. Application installation is simple & takes care of the USB driver installation

^{*} Other Newport display meters are available - please contact your local MKS sales representative



^{**} Additional options from MKS Ophir are available. Please visit www.ophiropt.com or contact your Ophir sales representative for consultation

VGEN Component Selection Guide

Recommended Beam Profiler & Attenuators*



In addition to the average or instantaneous Watts or Joules of the laser beam, it is critical to understand how the power is spatially distributed in the cross-section of the beam. A beam profiler can help detect laser performance issues such as beam wander, jitter, divergence and astigmatism. MKS is the market leader with the largest installed base of laser beam profilers. With our unmatched accuracy, customizable layout, cutting edge R&D and global support system, we are ready to help our customers solve their most challenging problems.

VGEN Type	VGEN Model	Recommended beam profiler	Recommended Attenuator	Description					
	VGEN-QS-50								
VGEN-QS	VGEN-QS-HE-50		LDDQ CAM NIDQ						
VGEN-QS	VGEN-QS-HE-75		LBP2-SAM-NIR2	The LBP2-HR Laser Beam Profiler is a powerful software driven system					
	VGEN-QS-HE-100			with comprehensive beam diagnostic measurement features. It features a 1924 x 1448 pixel CCD camera for the wavelength range between 190 and 1100 nm. The easy to use graphical user interface includes all of the accuracy and ISO approved quantitative results. • The LBP2-SAM beam sampler operates by reflecting the incoming beam from the front surfaces of a pair of wedges through 90 degrees into the camera. Approximately 99% of the beam is transmitted through the beam sampler with 0.01% passed on to the available filter slides where you can					
	VGEN-G-10								
	VGEN-G-20								
VGEN-G	VGEN-G-HE-10	LBP2-HR-VIS2	LBP2-SAM-VIS2						
	VGEN-G-HE-20								
	VGEN-G-HE-30								
	VGEN-ISP-POD-20								
VOEN ICD DOD	VGEN-ISP-POD-30		LDDO CAM NIDO	add an additional attenuation up to ND6					
VGEN-ISP-POD	VGEN-ISP-POD-50		LBP2-SAM-NIR2						
	VGEN-ISP-POD-75								

^{*} Additional options from MKS Ophir are available. Please visit www.ophiropt.com or contact your Ophir sales representative for consultation

MKS Instruments is your one-stop-shop partner for all the critical components surrounding your workpiece. Working very closely with customers globally and with diverse applications ranging from PCB, ceramic and glass cutting & drilling to micromachining & solar cell processing, chances are we have already experienced & solved the challenges you may be facing now.

That is how we **Solve Together, Succeed TogetherTM**.

Make Light

LASERS & LIGHT SOURCES

Ultrafast, Q-switched DPSS, CW, quasi-CW, high-energy pulsed, tunable and fiber lasers, low power laser diode modules, HeNe lasers, incoherent sources, laser diode instrumentation, laser diode reliability & burn-in test systems, electro-optic modulators & accessories. Includes ILX Lightwave, New Focus, Oriel, and Spectra-Physics products and brands



MOTION CONTROL

Our motion product portfolio includes high precision XY stages, vertical stages, rotation stages, air bearing stages, custom-made motion systems, XPS high performance universal motion controller/driver and LMS-Pro laser machining software. Over the decades, we have served customers with diverse applications including ablation, ultrafast micromachining, laser additive manufacturing, laser cutting, scribing and drilling.



Manage Light

PRECISION OPTICAL SYSTEMS/ SUBASSEMBLIES

Precision subassemblies and subsystems encompass our knowledge & expertise in optics, lasers, opto-mechanics, motion control, & electro-optics to meet the most demanding customer needs for performance, reliability, value & schedule. Incorporating precision optics fabrication and coating capabilities and components, optical solutions for the DUV, VIS, and NIR spectral ranges are produced from prototype through volume production.



OPTICAL TABLES & VIBRATION ISOLATION

With nearly 50 years of vibration control and vibration isolation design and manufacturing experience, MKS Newport has become the industry standard for optical tables, isolation systems, and vibration control products. Our diverse offering includes optical tables, breadboards, vibration isolators, Guardian Active Isolation workstations and custom built solutions



Measure Light

LIGHT ANALYSIS

MKS offers industry leading tools for measuring power or energy of an optical beam, profiling a laser, locating the position of a beam, spectral analysis, or characterizing a laser pulse. In addition to Newport brand optical meters, optical sensors, and beam characterization Instrumentation, our Ophir Photonics business offers a diverse selection of these products as well.



MKS Instruments, Inc. (NASDAQ: MKSI) is a \$1.9B global provider of instruments, subsystems and process control solutions that measure, control, power, monitor and analyze critical parameters of advanced manufacturing processes to improve process performance and productivity. Our products are derived from our core competencies in pressure measurement and control, materials delivery, gas composition analysis, control and information technology, power and reactive gas generation, vacuum technology, photonics, lasers, optics and motion control.

The laser measurement sensors, power meter & PC interface, beam profilers & attenuators listed in this document are RoHS compliant



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